



Speakers

Opening

Sunao Ishihara

Key note lecturer

Takeo Watanabe

Invited speakers

Rod Loewen

Norio Nakamura

Kentaro Harada

Naoki Kitano

Geert Vandenberghe

Jan van Schoot, Jos Benschop, Sjoerd Lok,
Eelco van Setten, Ruben Maas, Kars Troost,
Jo Finders, Paul Graeupner

Session Chairs

Hidemi Ishiuchi

Ryoichi Hajima

Soichi Inoue

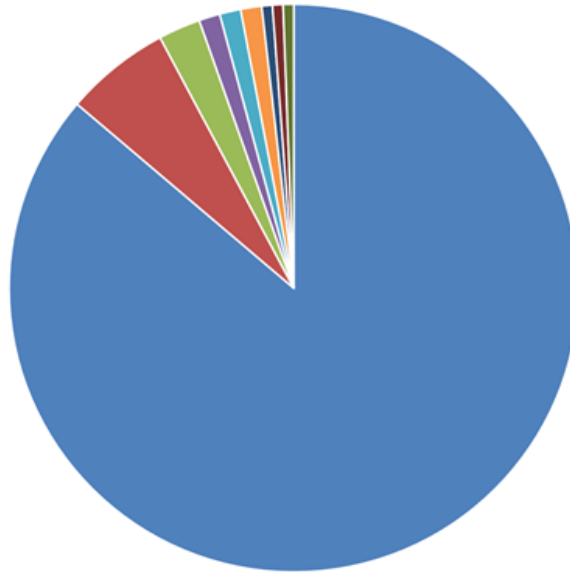


Participants

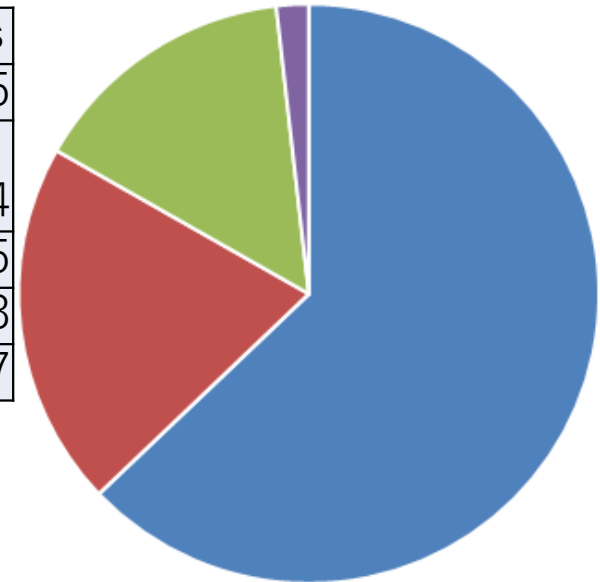
Number of registers;

167 @20/January/2021

Country	Registers
Japan	144
United States	10
China	4
Korea	2
Netherlands	2
Slovenia	2
Belgium	1
Germany	1
Taiwan	1
	167



Affiliation	registers
Company	105
Research Institute	34
University	25
Other	3
	167





Organizers

EUV-FEL Light Source Study Group for Industrialization
High energy accelerator Research Organization (KEK)
Center for Applied Superconducting Accelerator

EUV-FEL Light Source Study Group for Industrialization



Special Thanks

Workshop secretary; Hitomi Kusama

